

U.S. DEPARTMENT OF COMMERCE  
PATENT AND TRADEMARK OFFICE

**SUPPLEMENTAL INFORMATION  
DISCLOSURE STATEMENT**

Docket Number  
10020/29701

Application Number  
10/690,704

Filing Date  
October 23, 2003

Examiner  
TUROCY, David P.

Art Unit  
1762

Invention Title  
**METHOD AND APPARATUS FOR  
DEPOSITING MATERIAL**

Inventor(s)  
SHTEIN et al.

Address to:

Mail Stop Amendment  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

I hereby certify that this correspondence is being deposited with the United States Postal Service with sufficient postage as first class mail in an envelope addressed to: Mail Stop Amendment, Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450 on

Date: 24 Feb 05

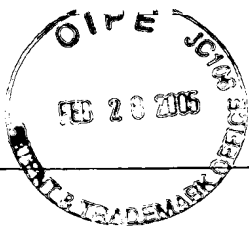
Signature: Patrick J. Birde  
Patrick J. Birde (Reg. No. 29,770)

1. In accordance with the duty of disclosure under 37 C.F.R. § 1.56 and in conformance with the procedures of 37 C.F.R. §§ 1.97 and 1.98 and M.P.E.P. § 609, attorneys for Applicants hereby bring the following references to the attention of the Examiner. The references are listed on the attached modified PTO Form No. 1449. It is respectfully requested that the information be expressly considered during the prosecution of this application, and that the references be made of record therein and appear among the "References Cited" on any patent to issue there from.
2. The filing of this Information Disclosure Statement and the enclosed PTO Form No. 1449, shall not be construed as an admission that the information cited is prior art, or is considered to be material to patentability as defined in 37 C.F.R. § 1.56(b).
3. A copy of each patent, publication or other information listed on the modified PTO form 1449 is enclosed.
4. The Commissioner is hereby authorized to charge payment of the 37 C.F.R. §1.17(p) (submission of an information disclosure statement under §1.97(c)) fee of **\$180.00** and any additional fees that may be required to the deposit account of **Kenyon & Kenyon**, deposit account number **11-0600**.

Dated: 24 Feb 05

By: Patrick J. Birde  
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<b>INFORMATION DISCLOSURE STATEMENT BY APPLICANT</b>	DOCKET NO. 10020/29701	SERIAL NO. 10/690,704
	APPLICANT SHTEIN et al.	
	FILING DATE October 23, 2003	GROUP 1762

**U. S. PATENT DOCUMENTS**

EXAMINER INITIAL	DOCUMENT NUMBER	PUBLICATION DATE	NAME	CLASS	SUBCLASS	FILING DATE

**FOREIGN PATENT DOCUMENTS**

EXAMINER INITIAL	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION	
						Yes	No
	WO 02/087787	November 7, 2002	PCT			X	
	WO 03/020999	March 13, 2003	PCT			X	

**NON PATENT LITERATURE DOCUMENTS**

EXAMINER INITIAL		AUTHOR, TITLE, DATE, PERTINENT PAGES, ETC.
		Shtein et al., "Direct mask-free patterning of molecular organic semiconductors using organic vapor jet printing", Journal of Applied Physics, Volume 96, Number 8, pp. 4500-4507, October 15, 2004.

EXAMINER	DATE CONSIDERED
EXAMINER: Initial if citation considered, whether or not citation is in conformance with M.P.E.P. 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.	